

**In the Specification**

At page 1, the paragraph inserted before the "Technical Field" by the amendment dated October 3, 2003, has been replaced with the paragraph shown below:

**CROSS REFERENCE TO RELATED APPLICATION**

This patent application is a Continuation Application of U.S. Patent Application Serial No. 10/128,933 filed April 23, 2002, now U.S. Patent No. 6,635,558 which issued October 21, 2003, entitled "Semiconductor Processing Methods Of Forming A Contact Opening To A Conductive Line and Methods of Forming Substrate Active Area Source/Drain Regions," naming Werner Juengling as inventor, which is a Continuation Application of U.S. Patent Application Serial No. 09/141,777 filed August 27, 1998, now U.S. Patent No. 6,395,623 B1 which issued May 28, 2002, the disclosures of which are hereby incorporated herein by reference.